

Sir:



## EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 1734

PATENT Customer No. 22,852 Attorney Docket No. 4173.0438

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re	Application of:	<u>}</u>
Tetsuya KUROSAWA		) Group Art Unit: 1734
Application No.: 10/665,206		) Examiner: Osele, Mark A.
Filed:	September 22, 2003	<i>)</i> )
For:	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND MANUFACTURING APPARATUS OF SEMICONDUCTOR DEVICE	) Confirmation No.: 5743 ) Mail Stop AF )
P.O. I	nissioner for Patents Box 1450 Indria, VA 22313-1450	

## REQUEST FOR RECONSIDERATION AFTER FINAL

In reply to the Final Office Action mailed August 2, 2007, the period for response to which extending through November 2, 2007, Applicant requests the Examiner's reconsideration in view of the remarks that follow.